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TRANSMITTAL FORM		Application Number	10/053,357
		Filing Date	Jan 17, 2002
		First Named Inventor	Sarfaty, Moshe
		Group Art Unit	2881
		Examiner Name	Unknown
Total Number of Pages in This Submission		Attorney Docket Number	4734/AMI-00-04

ENCLOSURES (check all that apply)

<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached	<input type="checkbox"/> Assignment Papers (for an Application) <input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s)	<input type="checkbox"/> After Allowance Communication to Group <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input checked="" type="checkbox"/> Other Enclosure(s) (please identify below): 1. PTO Form 1449 with eight (8) references 2. Return Receipt Postcard to Applied Materials, Inc. 3. Return Receipt Postcard to Kenneth C. Brooks
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Sarfaty, et al.

PATENT APPLICATION

Serial No.: 10/053,357

Group Art Unit: 2881

Filing Date: January 17, 2002

Examiner: Unknown

For: SPECTRAL REFLECTANCE FOR IN-SITU FILM CHARACTERISTIC
MEASUREMENTS

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner
for Patents
Washington, D.C. 20231

Sir:

The following information is submitted in compliance with Applicants' duty of disclosure under 37 C.F.R. § 1.56. Form PTO-1449 and a copy of each reference recited below accompanies this document. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

ISSUED PATENTS

<u>Patent Number</u>	<u>Inventor</u>	<u>Grant Date</u>
5,218,193	Miyatake	Jun. 8, 1993
5,355,219	Araki et al.	Oct. 11, 1994
6,088,103	Everett et al.	Jul. 11, 2000

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FOREIGN PATENT DOCUMENTS

<u>Document Number</u>	<u>Inventor</u>	<u>Publication Date</u>
EP 0867775	Kaisha	Sep. 30, 1998
WO 02/10721	Bailey et al.	Feb. 7, 2002

NON-PATENT DOCUMENTS

Uchida et al. A mask-to-wafer alignment gap setting method for x-ray lithography using gratings, J. Vac. Sci. Technol. B 9(6), Nov/Dec 1991, pp. 3202-3206.

Haisma et al. Mold-assisted nanolithography: A process for reliable pattern replication, J. Vac. Sci. Technol. B 14(6), Nov/Dec 1996, pp. 4124-4128.

White et al. Novel alignment system for imprint lithography, J. Vac. Sci. Technol. B 18(6), Nov/Dec 2000, pp. 3552-3556.

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Respectfully Submitted,



Kenneth C. Brooks
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